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PATENT
Customer No. 22,852
Attorney Docket No. 04329.3139-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Mitsuaki IZUHA et al.) Group Art Unit: 2811
)
Application No.: 10/660,555) Examiner: Vu, Quang D.
)
Filed: September 12, 2003)
)
For: MOSFET FORMED BY USING SALICIDE)
PROCESS AND METHOD OF)
MANUFACTURING THE SAME)

Commissioner for Patents and Trademarks
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

RESPONSE TO RESTRICTION REQUIREMENT

In the Office Action dated June 25, 2004, with a period for response extending through July 25, 2004, the Examiner required restriction under 35 U.S.C. § 121 between the following groups of claims:

Group I - Claims 1-6, characterized by the Examiner as drawn to a semiconductor device; and

Group II - Claims 7-14, characterized by the Examiner as drawn to a method of manufacturing a semiconductor device.

Applicants provisionally elect to prosecute the group characterized by the Examiner as Group I, claims 1-6, without traverse.

Please grant any extensions of time required to enter this response and charge any additional required fees to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: July 20, 2004

By: Rajeev Gupta
Rajeev Gupta
Reg. No. 55,873